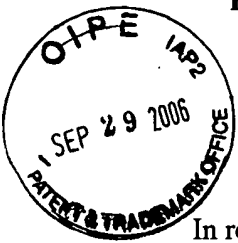


10-02-06

1fw



Express Mail No. 808084808US

Date Mailed: September 29, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Jeanne HAUBRICH, et al.

Appl. No.: 10/666,912

Filed: September 19, 2003

For: **PROCESS FOR FORMING A
PATTERNED THIN FILM
STRUCTURE ON A SUBSTRATE**

Art Unit: 1762

Confirmation No. 6475

Examiner: Turocy, David P.

Atty. Docket: 07783.0054.CPUS02

RESPONSE TO OFFICE ACTION

MS AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in Response to the Office Action dated September 25, 2006, and is submitted by the due date of October 25, 2006.

Applicant believes that there is no fee associated with the submission of this matter. However, if there is a fee deficiency, the U.S. Patent and Trademark Office is authorized to charge the fee to Deposit Account No 08-3038.